

External Modulation of Terahertz Quantum Cascade Lasers Using Metamaterials

SAND2008-6974C



I. Brener,¹ X. G. Peralta,¹ W. J. Padilla,² E. W. Young,¹ A.
J. Hoffman,³ M. J. Cich,¹ R. D. Averitt,⁴ M. C. Wanke,¹ J.
B. Wright,¹ H.-T. Chen,⁵ J. F. O'Hara,⁵ A. J. Taylor,⁵
J. Waldman,⁶ W. D. Goodhue,⁶ J. Li⁶

¹CINT, Sandia National Laboratories

²Boston University

³Princeton University

⁴Boston College

⁵MPA-CINT, Los Alamos National Laboratory

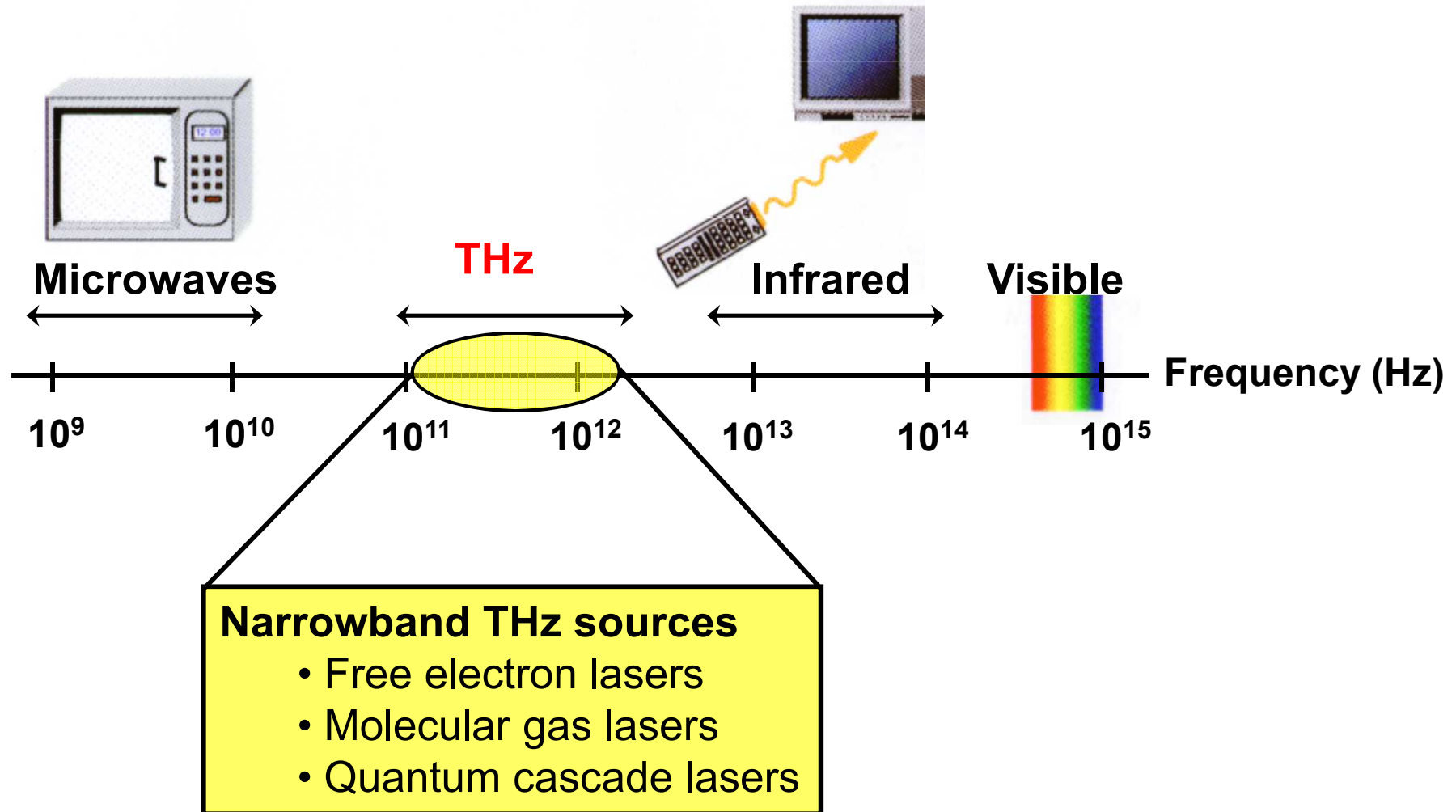
⁶University of Massachusetts Lowell

October 22, 2008.

Sandia is a multiprogram laboratory operated by Sandia Corporation, a Lockheed Martin Company, for the US DOE's NNSA under Contract DE-AC04-94AL85000. Los Alamos National Laboratory is operated by Los Alamos National Security, LLC, for the NNSA of the US DOE under contract DE-AC52-06NA25396.

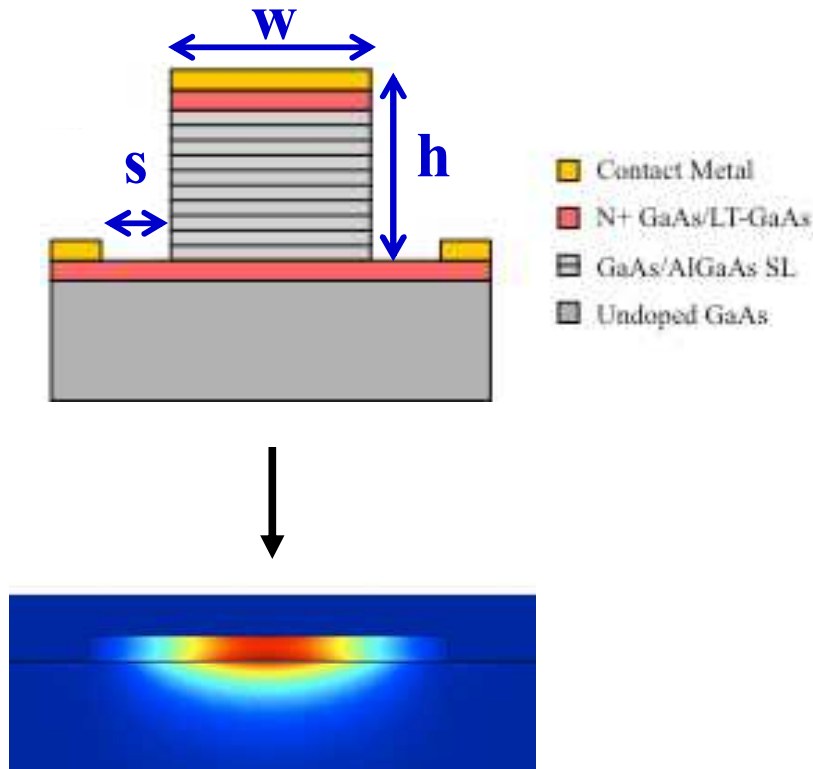


The terahertz region



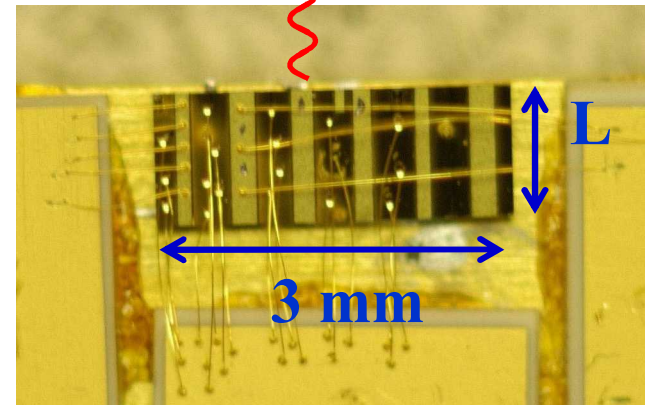
Overview of plasmon waveguide THz quantum cascade lasers (QCL)

Side view



Demichel, *Opt. Exp.*, **14**, 5335, 2006

Top view

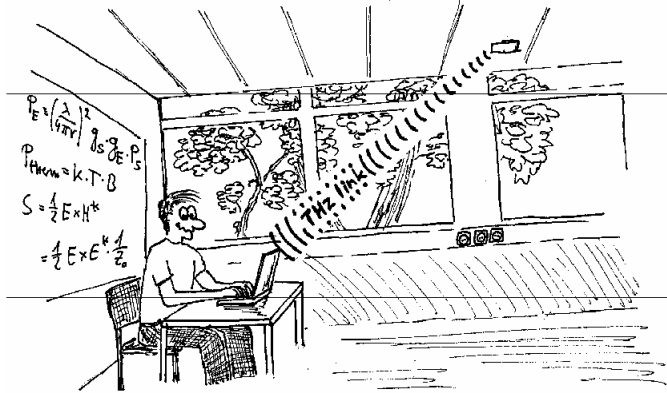


6 QCLs integrated on chip

QCLs provided by UMass Lowell and processed at SNL.

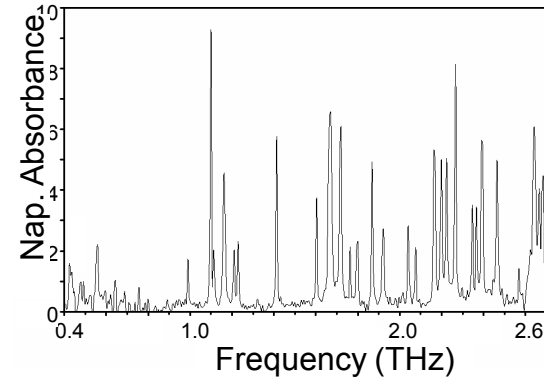
Emerging applications of THz QCLs

Communications



www.cpmoh.cnrs.fr/html/UserFiles/File/Bombannes/Frankreich-Koch.pdf

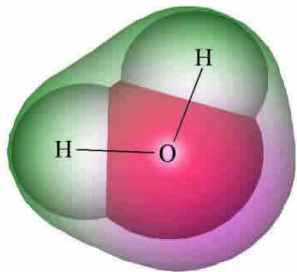
Spectroscopy



R. J. Foltynowicz, Sandia report 2005-5709.

Sensing

Chemical



Biological



Imaging

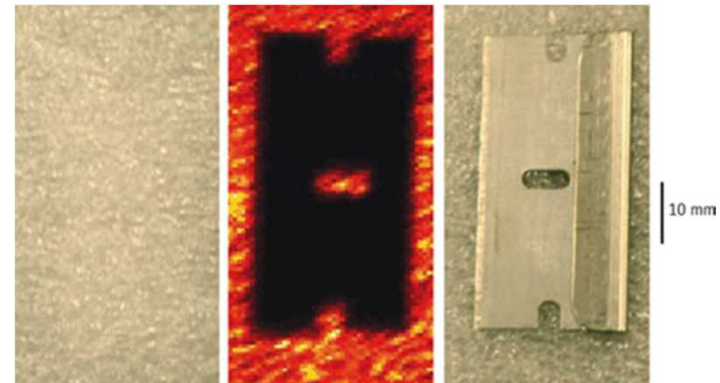


Image taken by I. Brener at SNL.

Emerging applications of THz quantum cascade lasers

Communications

Spectroscopy

Need for THz modulators

- Variable attenuators
- Lock-in detection at high frequencies for high resolution spectroscopy
- Pulse picking applications
- Active mode locking
- Sideband generation

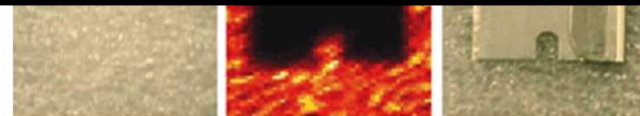
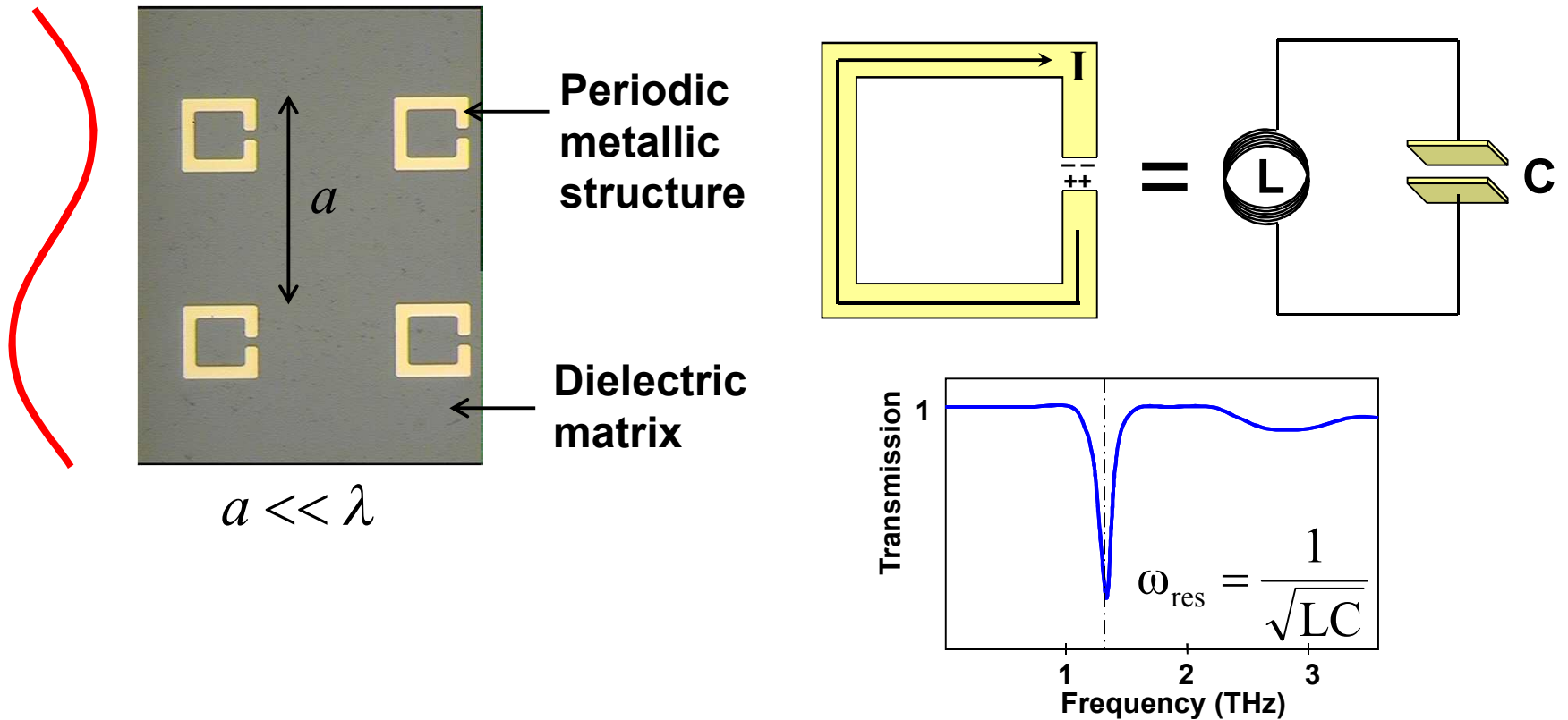


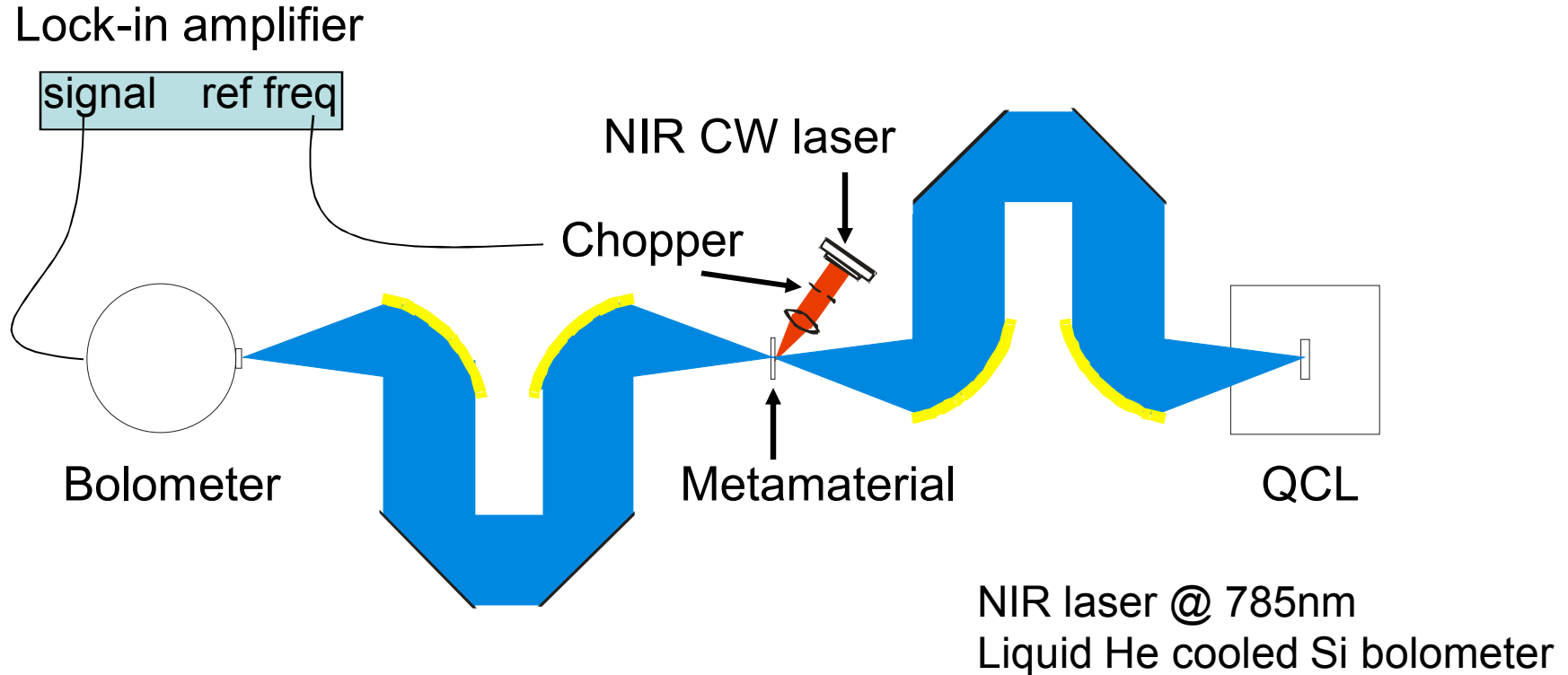
Image taken by I. Brener at SNL.

Active metamaterials can be used as THz modulators



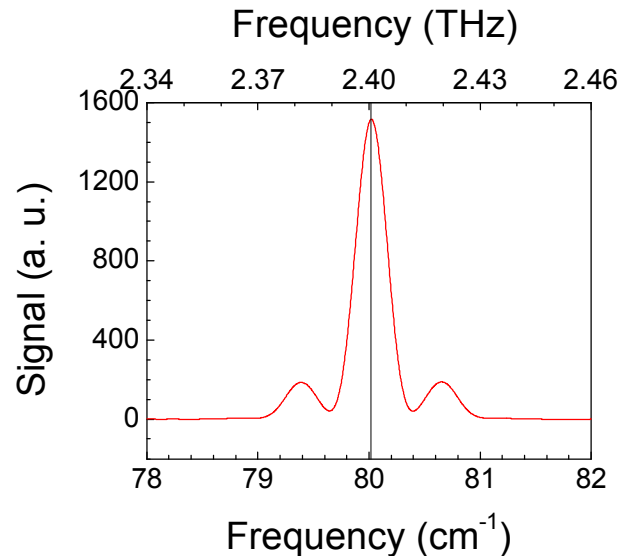
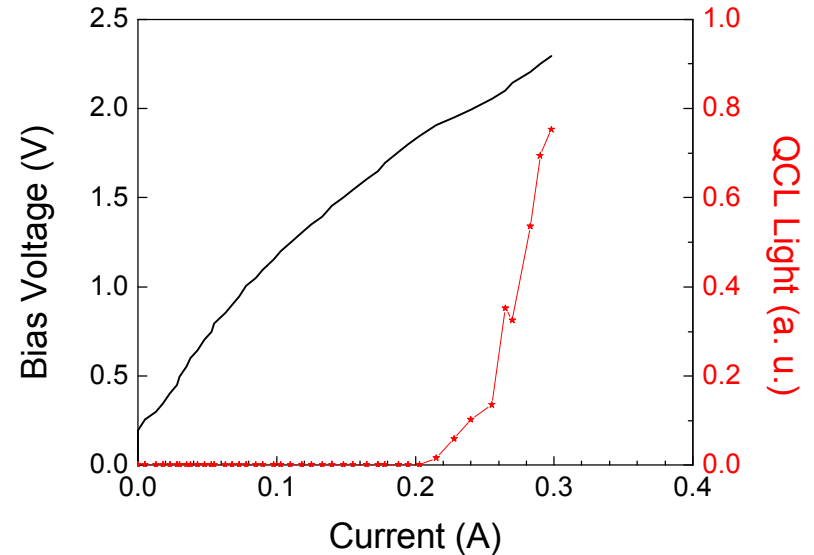
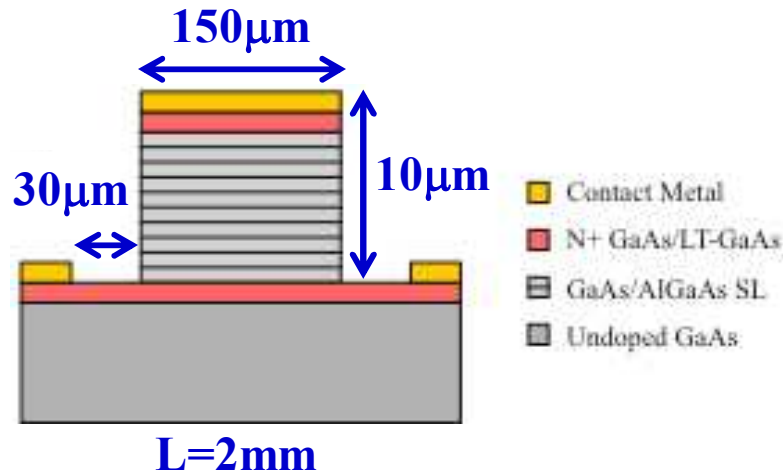
The individual units are designed to have specific electromagnetic properties.

Scheme for optical modulation



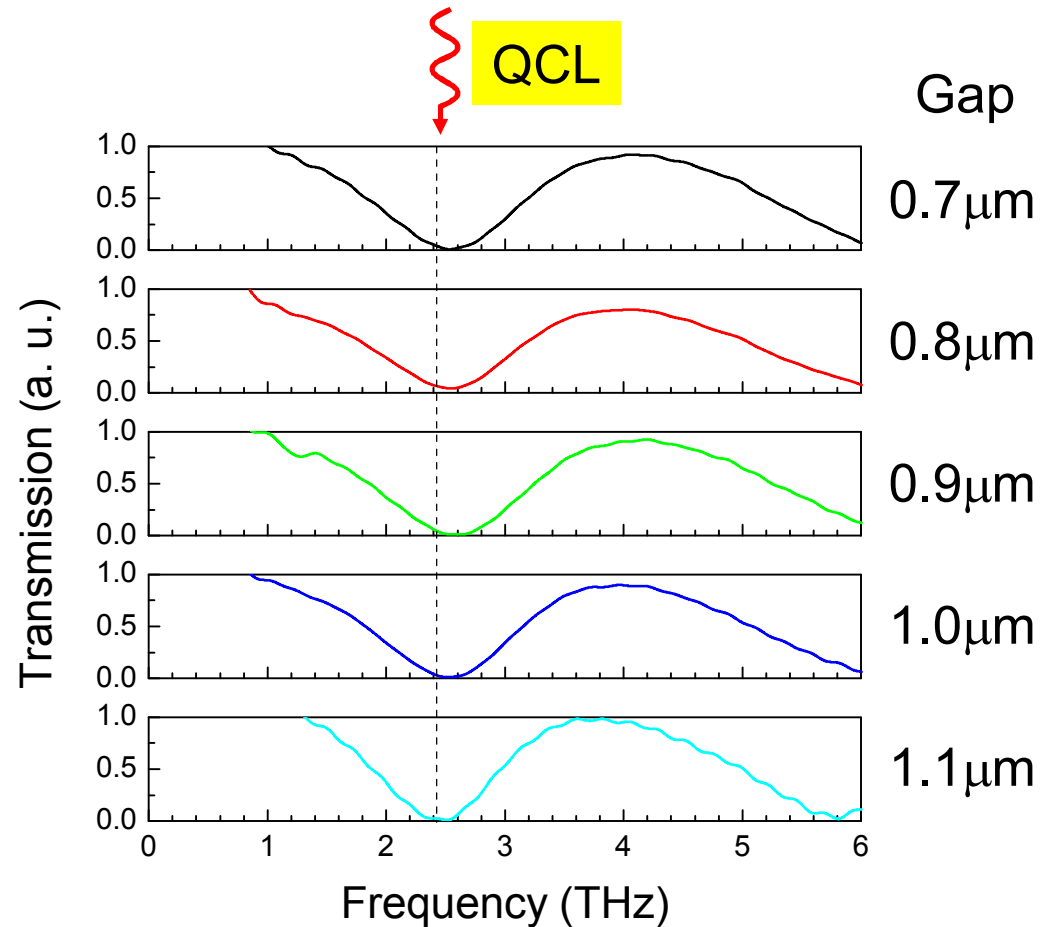
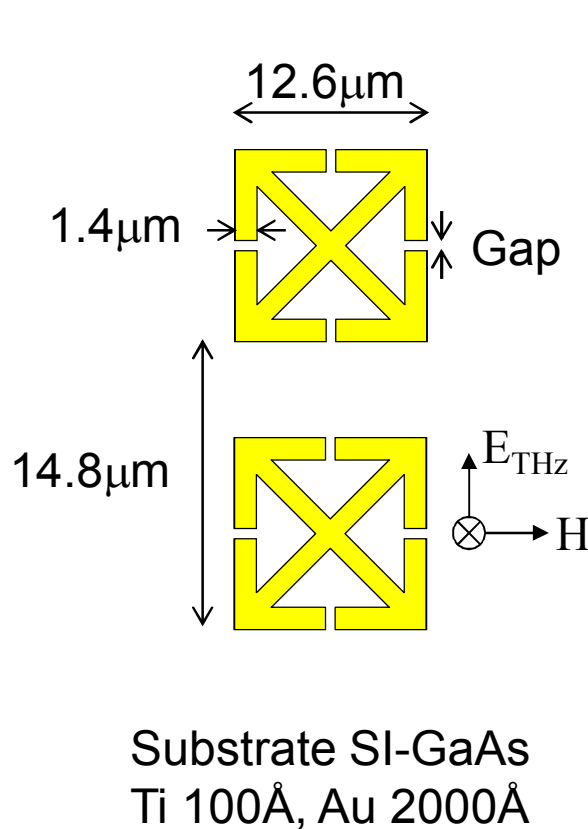
NIR laser $\rightarrow$ $\uparrow N_e$ photocarriers $\rightarrow$ shorts gap $\rightarrow$ $\uparrow T$

Characteristics of the 2.4THz QCL



$T = 4.4\text{K}$
Bias $V = 2.22\text{V}$
 $I = 290\text{ mA}$

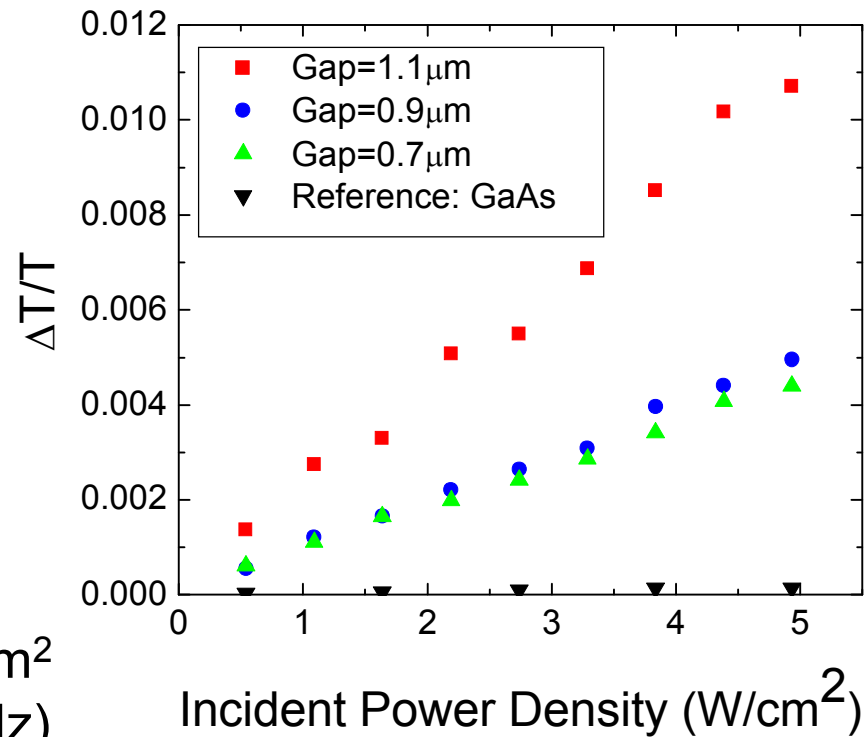
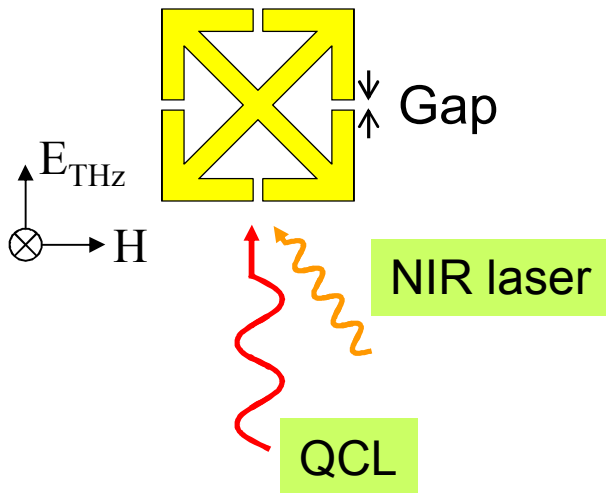
Gap size dependence of E2 metamaterial transmission spectra



CHECK Ne

Reference Si-GaAs substrate

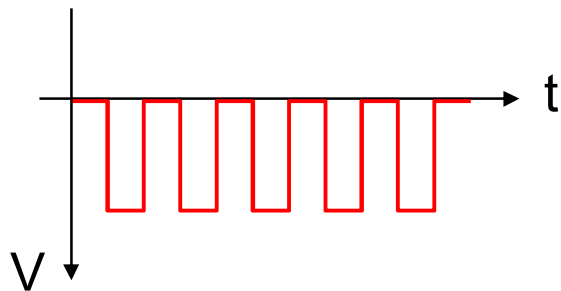
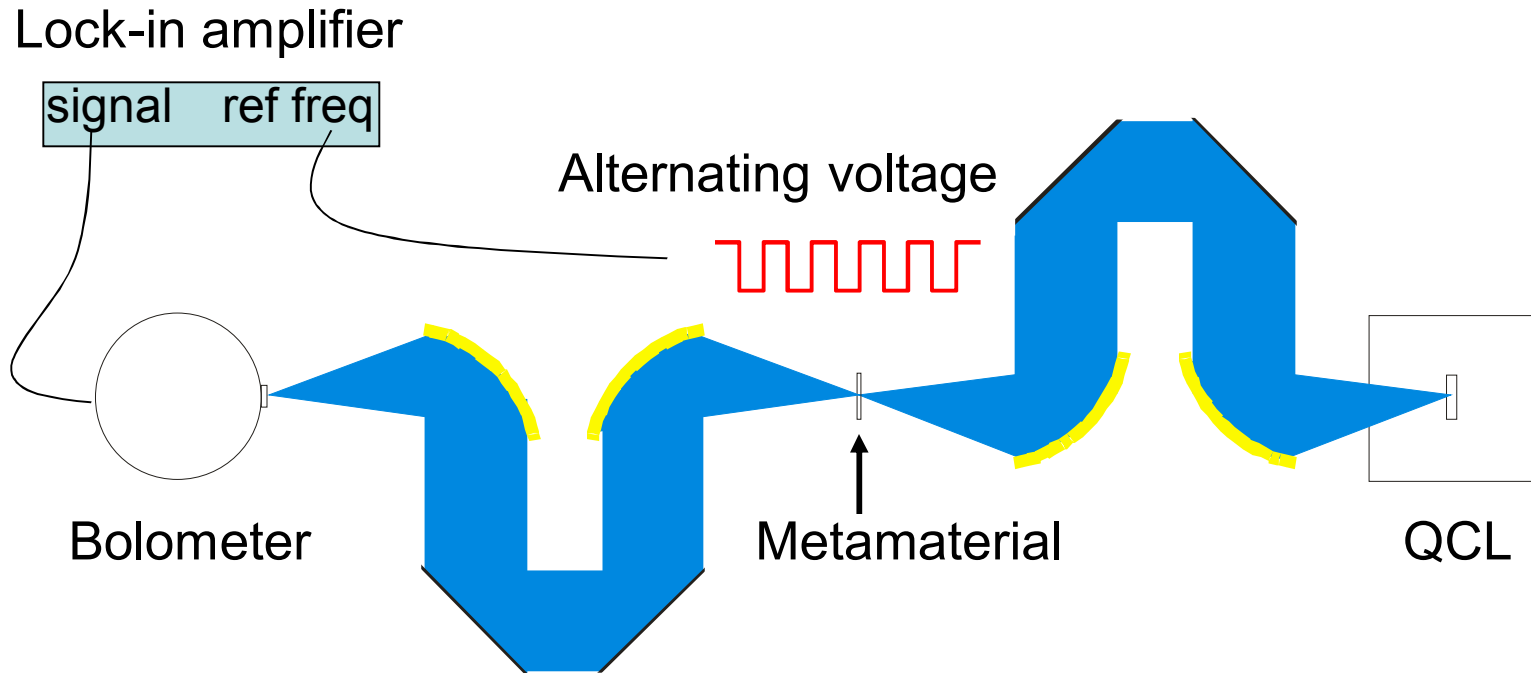
Optical modulation of a 2.4THz QCL using E2 metamaterials of varying gap sizes



Max. power density of 4.93 W/cm^2 gives $N_e \sim 10^{14} \text{ cm}^{-3}$ ($\omega_p \sim 0.3 \text{ THz}$)

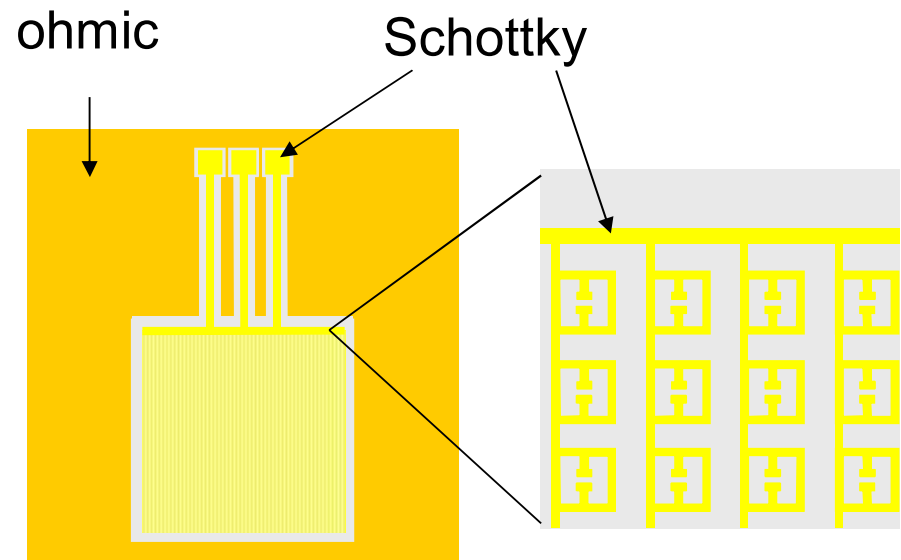
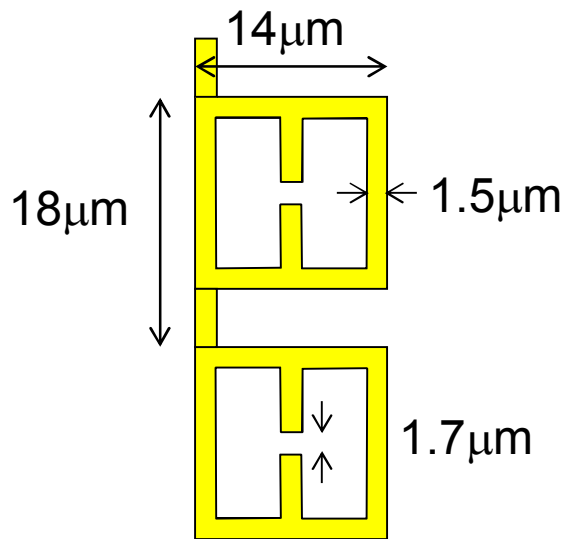
Change the substrate to increase N_e and reduce carrier lifetime to improve the modulation depth.

Scheme for electrical modulation



Apply $-V_{\text{gate}} \rightarrow \downarrow N_e \rightarrow$ reduces conductivity near the gap $\rightarrow \downarrow T$

Metamaterial design for electrical modulation



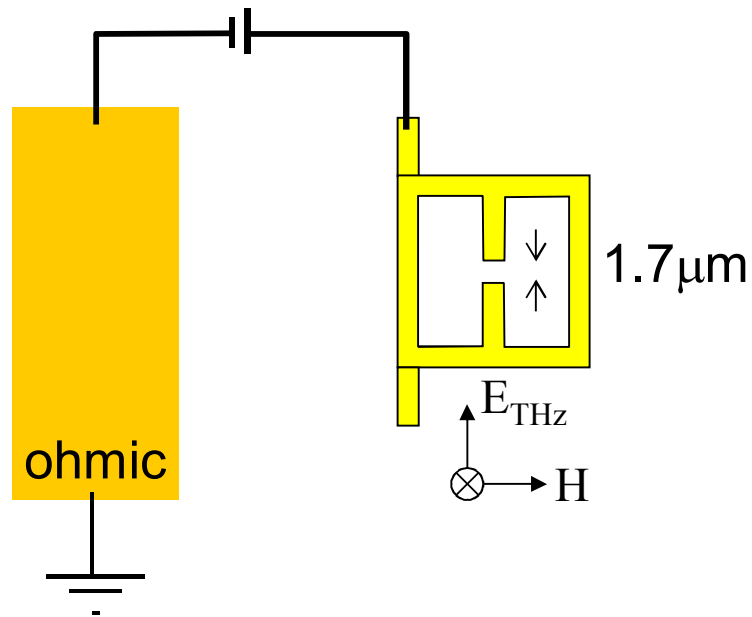
Substrate SI-GaAs

$N_e = 2 \times 10^{16} \text{ cm}^{-3}$

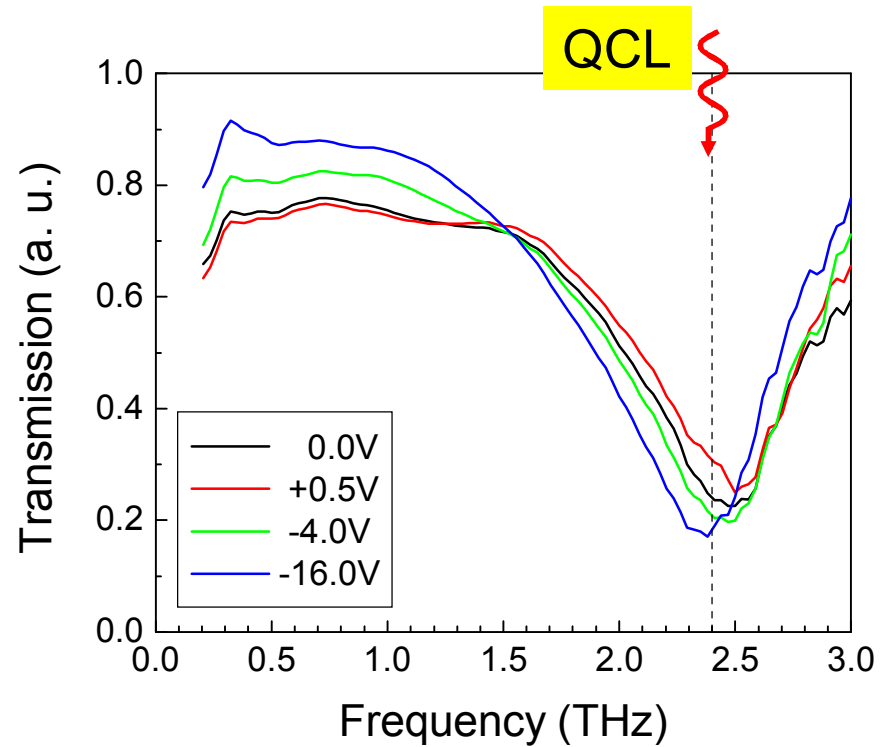
Gate: Ti 100Å, Au 2000Å

Ohmic: Ge 260Å, Au 540Å, Ni 150Å, Au 2000Å

Gate bias dependence of $1.7\mu\text{m}$ gap E4 metamaterial transmission spectra

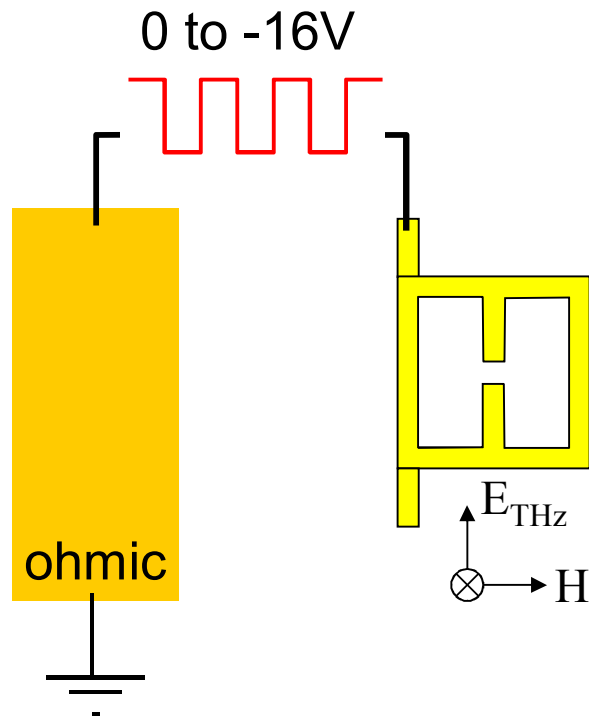


Applied constant gate voltage.

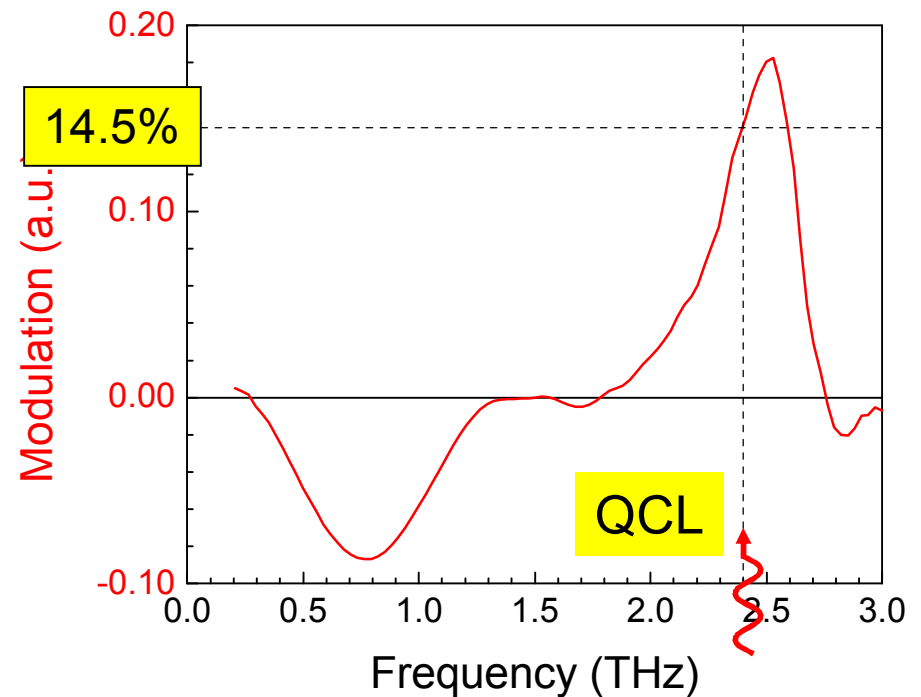


Reference Si-GaAs substrate

Electrical modulation of the metamaterial transmission measured using THz-TDS

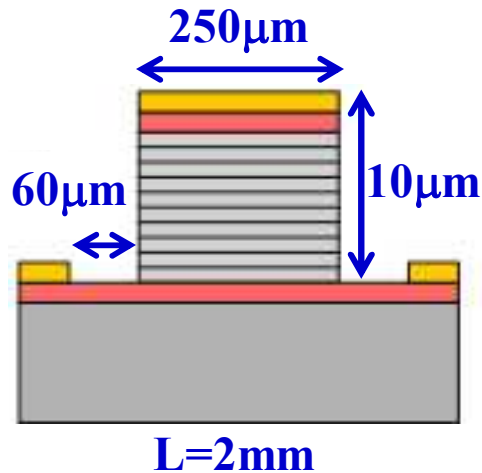


Applied alternating gate voltage.

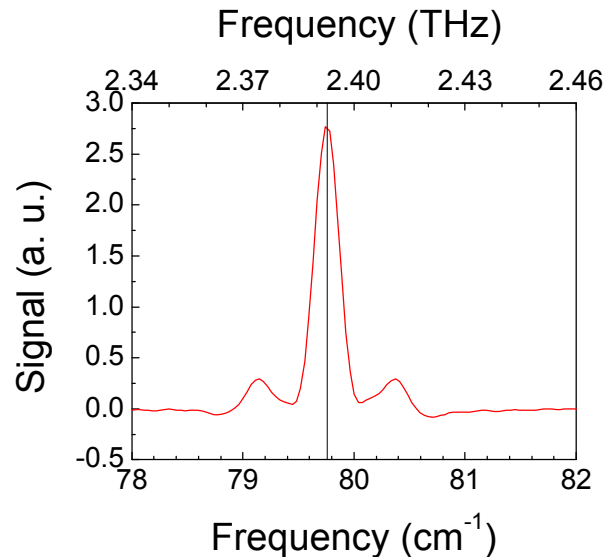
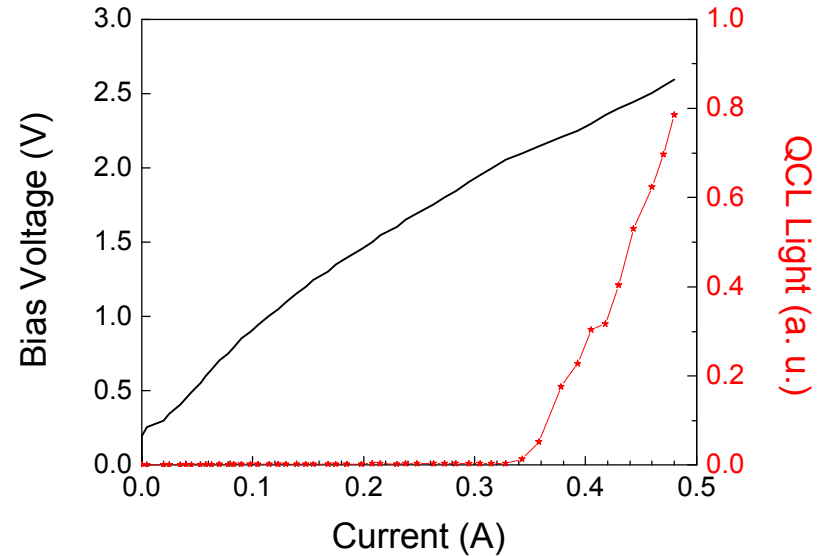


Reference metamaterial @ 0V

Characteristics of the 2.39THz QCL

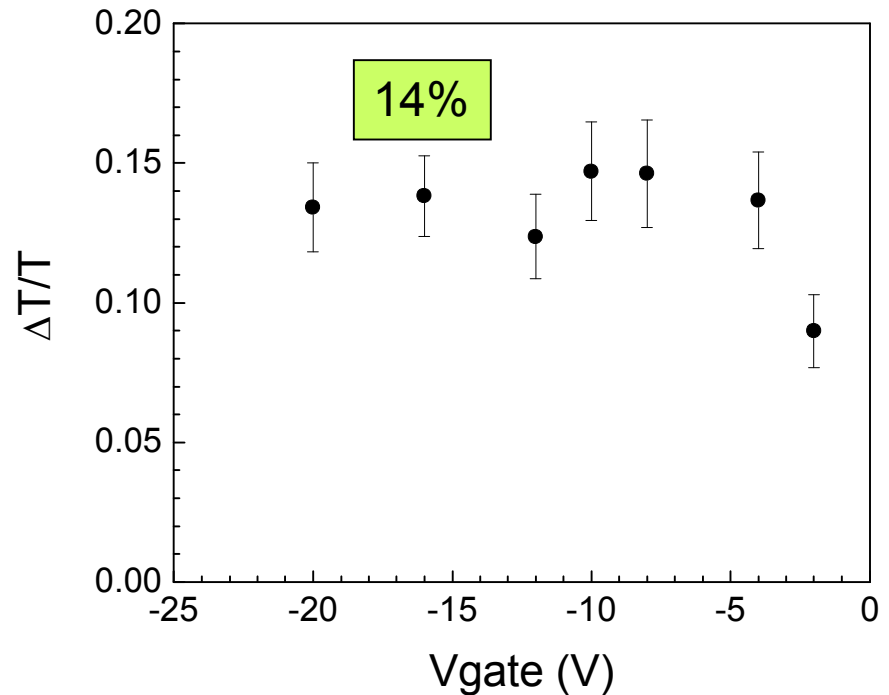
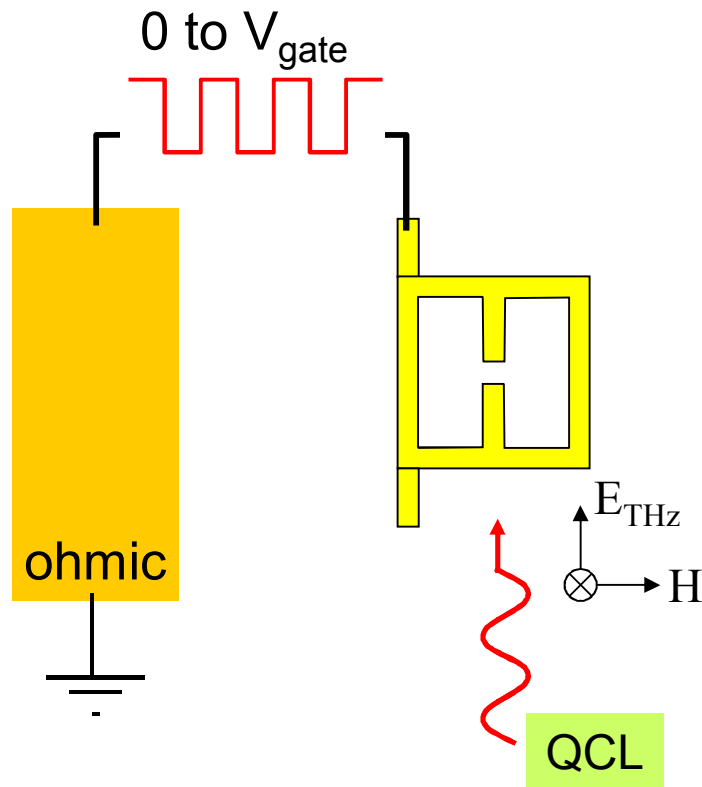


- Contact Metal
- N+ GaAs/LT-GaAs
- GaAs/AlGaAs SL
- Undoped GaAs



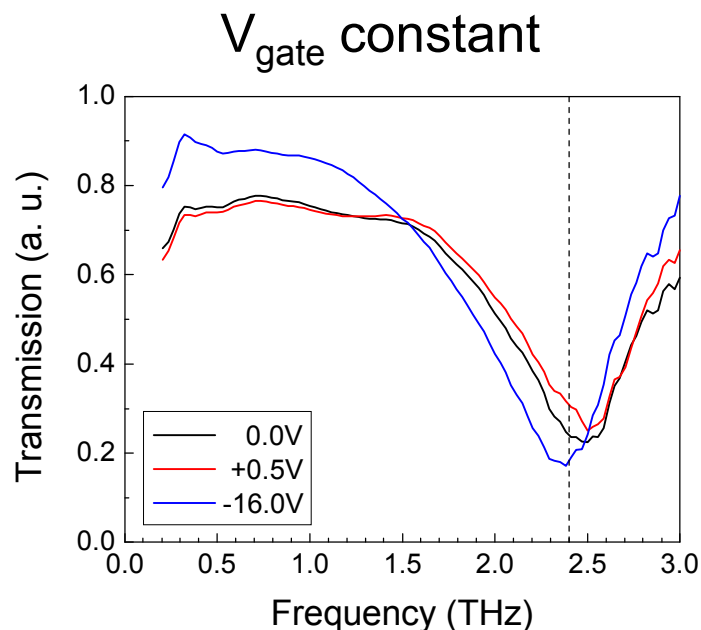
$T = 4.4\text{K}$
Bias $V = 2.6\text{V}$
 $I = 460\text{ mA}$

Electrical modulation of a 2.39THz QCL with a 1.7 μm gap E4 metamaterial



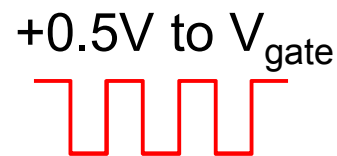
Estimated modulation speed is $f_c = (2\pi RC)^{-1} = 2.5\text{MHz}$.

Can improve the performance by biasing between +0.5V and -16V

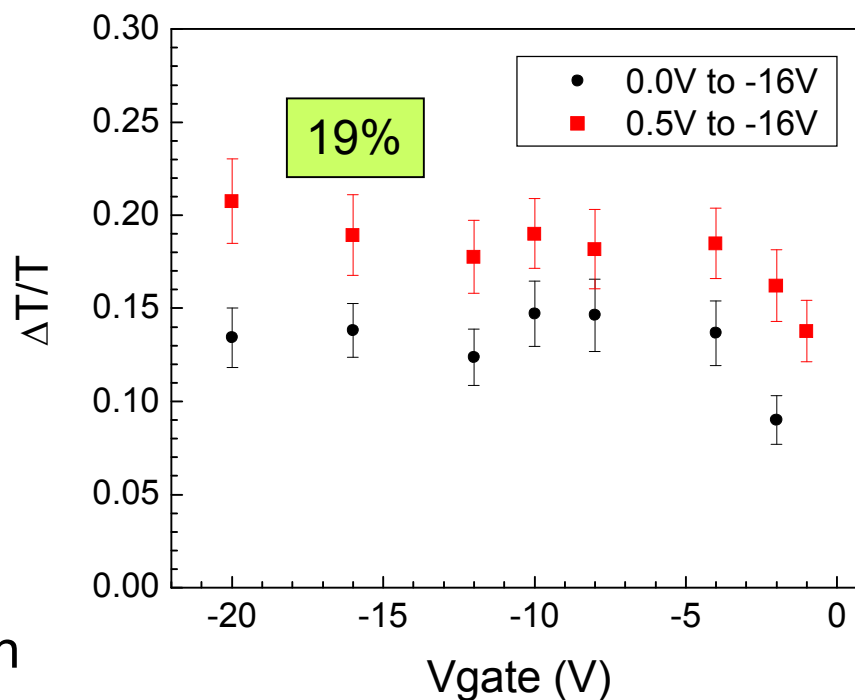


Reference Si-GaAs substrate

Initial $N_e = 2 \times 10^{16} \text{ cm}^{-3}$
($\omega_p \sim 1.34 \text{ THz}$) is not high enough
to efficiently short circuit the gap.



$+V_{\text{gate}} \rightarrow \uparrow N_e \rightarrow \uparrow \text{modulation depth}$

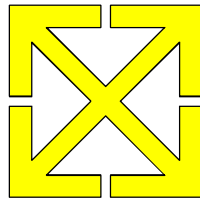


Summary and potential improvements

Accomplishments

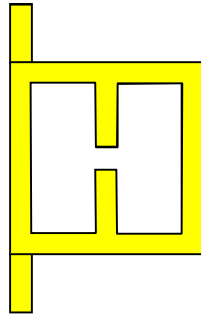
Optical Modulation at 2.4THz

- Modulation depth of 1%



Electrical Modulation at 2.39THz

- Modulation depth of 19%



Improvements

- Change the substrate to increase N_e
- Change the substrate to reduce carrier lifetime
- Increase N_e (minimum to $7 \times 10^{16} \text{ cm}^{-3}$, then $\omega_p \sim 2.5\text{THz}$)
- Reduce area to increase modulation speed

Acknowledgements



- Sandia LDRD Program
- LANL LDRD program
- IC Postdoctoral Fellowship Program
- CINT

